

## AMENDMENTS TO THE CLAIMS

The following listing of claims replaces all prior versions, and listings, of claims in the application:

1. (Currently amended) A method of managing radiation, the method comprising:

providing a semiconducting device having a two-dimensional carrier gas, wherein the semiconducting device comprises at least one of: a heterodimensional diode, a field effect transistor array, a heterodimensional diode array, or an array of rectifying contacts;

exciting the carrier gas by shining a laser pulse having a duration of approximately one femtosecond to ten picoseconds onto the semiconducting device; and

adjusting a frequency of the radiation to a desired frequency using a voltage applied to the semiconducting device.

2. (Previously presented) The method of claim 1, wherein the radiation comprises at least one of: terahertz radiation or microwave radiation.

3. (Previously presented) The method of claim 1, wherein the adjusting adjusts at least one of: a gate bias voltage or a drain bias voltage.

Claims 4-6 (Canceled)

7. (Previously presented) The method of claim 1, wherein the exciting includes shining the laser pulse onto at least one of: a top side or a bottom side of the semiconducting device.

8. (Currently amended) A method of generating radiation using a field effect transistor, the method comprising:

shining a laser pulse onto at least one of: a gate-source spacing, a gate, a gate-drain spacing, or a substrate of the field effect transistor; and

adjusting a frequency of the radiation to a desired frequency by adjusting a carrier density of carriers in a channel of the field effect transistor, wherein the adjusting includes adjusting a gate length for the gate.

9. (Canceled)

10. (Currently amended) A method of generating radiation using a field effect transistor, the method comprising:

shining a laser pulse onto the field effect transistor; and

adjusting a frequency of the radiation to a desired frequency by adjusting a carrier density of carriers in a channel of the field effect transistor, wherein the field effect transistor comprises a transparent gate, and wherein the laser pulse is shone onto the transparent gate.

11. (Currently amended) A method of generating radiation using a field effect transistor, the method comprising:

shining a laser pulse onto the field effect transistor; and

adjusting a frequency of the radiation to a desired frequency by adjusting a carrier density of carriers in a channel of the field effect transistor, wherein the adjusting uses a bias voltage applied to a periodic grating gate of the field effect transistor.

12. (Canceled)

13. (Currently amended) A method of generating radiation using a field effect transistor, the method comprising:

shining a laser pulse onto at least one of: a gate-source spacing, a gate, a gate-drain spacing, or a substrate of the field effect transistor; and

adjusting a frequency of the radiation to a desired frequency by adjusting a carrier density of carriers in a channel of the field effect transistor, wherein the radiation comprises at least one of: terahertz radiation or microwave radiation.

14. (Currently amended) A method of generating radiation using a field effect transistor, the method comprising:

shining a laser pulse onto at least one of: a gate-source spacing, a gate, a gate-drain spacing, or a substrate of the field effect transistor; and

adjusting a frequency of the radiation to a desired frequency by adjusting a carrier density of carriers in a channel of the field effect transistor, wherein the laser pulse has a duration of approximately one femtosecond to ten picoseconds.

15. (Currently amended) A method of generating radiation using a heterodimensional diode, the method comprising:

shining a laser pulse onto at least one of a top side or a bottom side of the heterodimensional diode; and

adjusting a frequency of the radiation to a desired frequency using a voltage applied to the heterodimensional diode to adjust a frequency of a plasma wave in a two-dimensional carrier gas in the heterodimensional diode.

16. (Original) The method of claim 15, further comprising adjusting the frequency of the radiation by using a plurality of heterodimensional diodes.

17. (Original) The method of claim 15, further comprising shining a second laser pulse onto a substrate of the heterodimensional diode.

Claims 18-19 (Canceled)

20. (Original) The method of claim 15, wherein the heterodimensional diode includes at least one ohmic contact and at least one rectifying contact.

21. (Currently amended) A method of managing radiation, the method comprising:

providing a field effect transistor having a two-dimensional carrier gas and a periodic grating gate;

exciting the carrier gas using a laser pulse having a duration of approximately one femtosecond to ten picoseconds; and

adjusting a frequency of the radiation to a desired frequency using a voltage applied to the field effect transistor.

22. (Canceled)

23. (Previously presented) The method of claim 1, wherein the duration of the laser pulse comprises approximately twenty femtoseconds.

24. (Previously presented) The method of claim 1, wherein a photon energy of the laser pulse exceeds 1.42 electron Volts.

25. (Previously presented) The method of claim 15, wherein the laser pulse has a duration of approximately one femtosecond to ten picoseconds.

26. (Previously presented) The method of claim 15, wherein the radiation comprises at least one of: terahertz radiation or microwave radiation.

27. (Canceled)

28. (Currently amended) A method of managing radiation, the method comprising:

providing a field effect transistor having a two-dimensional carrier gas and a periodic grating gate;

exciting the carrier gas using a laser pulse having a duration of approximately one femtosecond to ten picoseconds; and

adjusting a frequency of the radiation to a desired frequency using a voltage applied to the field effect transistor, wherein the radiation comprises at least one of: terahertz radiation or microwave radiation.

29. (Previously presented) The method of claim 14, wherein the shining excites plasma oscillations and wherein an active layer in the field effect transistor traps the plasma oscillations as plasma waves.